

TSMC 00-151 Application no. 09/867,563

Application No.	:	09/867,563	Confirmation No.	_____
Applicant	:	Tsu Shih.		
File	:	05/31/2001		
TC/A.U.	:	1765		
Examiner	:	Chen, Kin Chan		
Docket No.	:	TSMC 00-151		
Customer No.	:	_____		

Commissioner of Patents
P.O. Box 1450
Alexandria VA 22313-1450

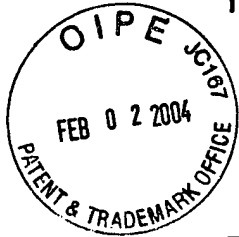
RESPONSE TO OFFICE ACTION

Sir:

In response to the Office Action of 10/29/2003, please amend the above-identified application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 3 of this paper.

Remarks/Arguments begin on page 9 of this paper.



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Application no. 09/867,563

Image

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1765

November 13, 2003

TO: Commissioner of Patents and Trademarks
P.O. Box 1450
Alexandria, VA 22313-1450

FROM: Stephen Ackerman Reg. No. 37,761
28 Davis Avenue
Poughkeepsie, N.Y. 12603

SUBJECT: Serial # 09/867,563
File Date: 05/31/2001
Inventor: Tsu Shih.
Examiner: Chen, Kin Chan
Art Unit: 1765
Title: A Method To Eliminate Via Poison Effect

RESPONSE TO FINAL OFFICE ACTION

This is in response to the Office Action dated 10/29/2003 Please amend
the above identified application for patent as follows:

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United
States Postal Service as first class mail in an envelope addressed to :
Commissioner of Patents and Trademarks, P.O. Box 1450, Alexandria, VA
22313-1450 on January 29, 2004.

Signature [Signature]
Stephen B. Ackerman, Reg. No. 37,761

Date: 1/29, 2004.